

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)	ATTY. DOCKET NO. 57810-074	SERIAL NO. 10/659 346
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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
<i>SLM</i>		JP P2002-93702A	03/29/2002	SANYO ELECTRIC CO LTD		(Japan w/English Abstract)	
<i>SLM</i>		JP P2001-189458A	07/10/2001	SANYO ELECTRIC CO LTD		(Japan w/English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
<i>JKL</i>		"Large Grain Poly-Si TFTs by Scanning CW Laser Crystallization," Hara et al. AM-LCD '02, Digest of Technical Papers, July 10-12, 2002 pp. 227-230
<i>JKL</i>		Extended Abstracts (The 48th Spring Meeting, 2001); The Japan Society of Applied Physics and Related Societies. JSAP Catalog Number: AP 011109-02 (03/28/2001) pg. 900
<i>JKL</i>		21st Century Version "A Handbook of Applied Forming for Thin Film," April 22, 2003

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